

## Patent Assignment Abstract of Title

**Total Assignments: 1****Applicati n #:** 09505695 **Filing Dt:** 02/17/2000**Patent #:** NONE**Issue Dt:****PCT #:** NONE**Publicati n #:** NONE**Pub Dt:****Inventors:** Ivan Berry, Mahmoud Dahimene, John Hallock, Michael Owens, Stuart Rounds**Title:** Method of photoresist ash residue removal**Assignment: 1**

<b>Reel/Frame:</b> <u>012422/0365</u>	<b>Received:</b> 01/09/2002	<b>Recorded:</b> 01/03/2002	<b>Mailed:</b> 02/26/2002	<b>Pages:</b> 8
---------------------------------------	--------------------------------	--------------------------------	------------------------------	--------------------

**Conveyance:** ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).**Assignors:** HALLOCK, JOHN**Exec Dt:** 03/23/2001OWENS, MICHAEL**Exec Dt:** 03/29/2001ROUNDS, STUART**Exec Dt:** 04/11/2001BERRY, IVAN**Exec Dt:** 04/11/2001DAHIMENE, MAHMOUD**Exec Dt:** 05/05/2001**Assignee:** AXCELIS TECHNOLOGIES, INC.55 CHERRY HILL DRIVE  
BEVERLY, MASSACHUSETTS 01915**Correspondent:** EPSTEIN, EDELL, SHAPIRO, FINNAN, ET ALMARTIN ABRAMSON  
1901 RESEARCH BOULEVARD  
SUITE 400  
ROCKVILLE, MARYLAND 20850

Search Results as of: 6/20/2003 10:33:33 A.M.

If you have any comments or questions concerning the data displayed, contact OPR / Assignments at 703-308-9723  
Web interface last modified: Oct. 5, 2002

Attorney: Mr. Martin Abramson